

Electronic Articles of Incorporation For

P22000079479
FILED
October 17, 2022
Sec. Of State
klovelace

CHIMICRON SEMICONDUCTOR INC

The undersigned incorporator, for the purpose of forming a Florida profit corporation, hereby adopts the following Articles of Incorporation:

Article I

The name of the corporation is:

CHIMICRON SEMICONDUCTOR INC

Article II

The principal place of business address:

5600 N FLAGLER DR
PH 2019
WEST PALM BEACH, FL. US 33407

The mailing address of the corporation is:

PO BOX 520788
FLUSHING, NY. US 11352

Article III

The purpose for which this corporation is organized is:

ANY AND ALL LAWFUL BUSINESS.

Article IV

The number of shares the corporation is authorized to issue is:

20000

Article V

The name and Florida street address of the registered agent is:

SIZHI LIN
5600 N FLAGLER DR
PH 2019
WEST PALM BEACH, FL. 33407

I certify that I am familiar with and accept the responsibilities of registered agent.

Registered Agent Signature: SIZHI LIN

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Article VI

The name and address of the incorporator is:

SIZHI LIN
PO BOX 520788

FLUSHING NY 11352

Electronic Signature of Incorporator: SIZHI LIN

I am the incorporator submitting these Articles of Incorporation and affirm that the facts stated herein are true. I am aware that false information submitted in a document to the Department of State constitutes a third degree felony as provided for in s.817.155, F.S. I understand the requirement to file an annual report between January 1st and May 1st in the calendar year following formation of this corporation and every year thereafter to maintain "active" status.

Article VII

The initial officer(s) and/or director(s) of the corporation is/are:

Title: P
SIZHI LIN
PO BOX 520788
FLUSHING, NY. 11352 US